



Inventor: Gurtej S. Sandhu, et al.

Title: Deposition Methods and Apparatuses Providing Surface Activation

Assignee: Micron Technology, Inc.

Serial No.: 09/652,533

Filing Date: August 31, 2000

Docket No. MI22-1385

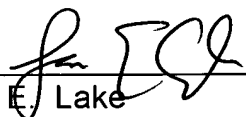
**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether any of the submitted references is prior art. Copies of the references are attached.

Citation of this reference is respectfully requested.

Respectfully submitted,

Dated: 17 Jul 2003

Attorney:   
James E. Lake  
Reg. No. 44,854

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Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
MI22-1385SERIAL NO.  
09/652,533LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)

APPLICANT Gurtej S. Sandhu

FILING DATE  
August 31, 2000GROUP  
2812

## U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,985,770	11/1999	Sandhu et al			
	AB	5,281,274	1/1994	Yoder			
	AC	5,366,555	11/1994	Kelly			
	AD	5,413,671	5/1995	Ketchum			
	AE	5,747,113	5/1998	Tsai			
	AF	6,306,216	10/2001	Kim et al			
	AG	5,116,640	5/1992	Mikami et al			
	AH						
	AI						
	AJ						
	AK						
	AL						

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclasses	Translation	
							Yes	No
	AM							
	AN							

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AO		
	AP		
	AQ		
	AR		

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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